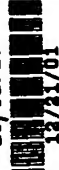


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PATENT NUMBER and  
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## U.S. UTILITY Patent Application

31046 U.S. PTO  
10/029158  
JCM37



APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10029158	12/21/2001	451	285	3723	PACIHOBA

**\*\*APPLICANTS:** Suh Nam; Melvin Jason; Oh Hilario;

**\*\*CONTINUING DATA VERIFIED:**

THIS APPLICATION IS A CIP OF 09/628,563 07/31/2000  
AND CLAIMS BENEFIT OF 60/259,016 12/29/2000

**\*\* FOREIGN APPLICATIONS VERIFIED:**

PCT/US01/41513 07/31/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials		ATTORNEY DOCKET NO A-69175-1/MSS
TITLE : Apparatus and method for chemical mechanical polishing of substrates		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for 0.6
Assistant Examiner		DRAWING	
ISSUE FEE Amount Due      Date Paid		Sheets Drwg.	Figs. Drwg.      Print Fig.
Primary Examiner		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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